

<b>Notice of References Cited</b>	Application/Control No. 10/540,379	Applicant(s)/Patent Under Reexamination KAWAZOE ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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*	N	JP6319986	11-1994	Japan		
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Steigerwald et al " Surface derivatization and isolation of semiconductor cluster molecules" J.Am. Chem. Soc. 1988, 110, 3046-3050.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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